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IPW

Docket No.: 071971-0390

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 53080
: :
Kunimasa TAKAHASHI, et al. : Confirmation Number: 6282
: :
Application No.: 10/553,845 : Group Art Unit: 2813
: :
Filed: October 20, 2005 : Examiner: Kayra Nart NEBZ
: :
For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR PRODUCING
THE SAME

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

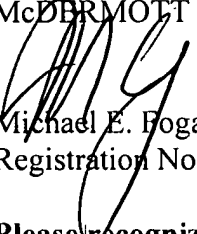
This Information Disclosure Statement is being submitted to correct typographical errors in the Form 1449 originally Submitted on October 20, 2005. The Japanese reference originally listed as JP 2002-012482 should read **JP 2000-012482**. Please note that a copy of the correct reference, JP 2000-012482 was submitted with the original information disclosure statement filed on October 20, 2005. A corrected PTO-Form 1449 is being filed herewith.

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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as our correspondence address.**